

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Shouichi MIYAWAKI, Hiroyuki TAKEUCHI and Yasumasa SAITO

Serial No.: Not Yet Known

Int'l Appl'n No.: PCT/JP2004/007957

Date Filed: Concurrently Herewith

Int'l Appl'n Filing Date: 8 June 2004

For: MAGNETIC RESONANCE IMAGING METHOD AND APPARATUS

Mail Stop PCT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

ATTN: DO/EO/US

Sir:

INFORMATION DISCLOSURE STATEMENT

Pursuant to the applicant's duty of disclosure, the information listed in the attached Form PTO-1449 is brought to the attention of the Examiner.

It is respectfully requested that the information cited in annexed Form PTO-1449 be considered by the Examiner in connection with the above-identified patent application, filed concurrently herewith, and that such art be made of record in said application.

The subject application is a U.S. national phase application under 35 U.S.C. 371 of International Application No. PCT/JP2004/007957. The enclosed items were cited in the International Search Report in connection with International Application No. PCT/JP2004/007957. A copy of the International Search Report is submitted concurrently herewith.

The citation of the listed items is not a representation that they constitute a complete or exhaustive listing of the relevant art or that these items are prior art. The items listed are submitted in good faith, but are not intended to substitute for the Examiner's search. It is

Application of: Shouichi MIYAWAKI et al.
Serial No.: Not yet known
Filed: Concurrently Herewith
Page 2

10/564249
Dkt. 1141/75707
IAP20 Rec'd PTO 11 JAN 2006

hoped, however, that in addition to apprising the Examiner of the particular items, they will assist in identifying fields of search and in making as full and complete a search as possible.

The filing of this Information Disclosure Statement is not an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).


According to the August 5, 2003 OG Notice published by the Patent and Trademark Office, the Office has waived the requirement under 37 C.F.R. §1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and each cited U.S. patent application publication for all U.S. national patent applications filed after June 30, 2003 and for all international application that have entered the national stage under 35 U.S.C. §371 after June 30, 2003.

Accordingly, copies are submitted herewith for only references listed on the annexed Form PTO-1449 that are not a U.S. patent or U.S. patent application publication.

The Office is hereby authorized to charge any fees that may be required for consideration of this Information Disclosure Statement and to credit any overpayment to our Deposit Account No. 03-3125.

Respectfully submitted,

Dated: January 11, 2006



Paul Teng, Reg. No. 40,837
Attorney for Applicants
Cooper & Dunham LLP
1185 Avenue of the Americas
New York, New York 10036
Tel.: (212) 278-0400

Form PTO-1449	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 1141/75707	Serial No. 10/504249 <small>Not Yet Known</small>
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)		Applicants: Shouichi MIYAWAKI et al.	
		Filing Date: Herewith	Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
	6 0 4 3 6 5 6	3-28-2000	Ma et al.			

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Subclass	Translation	
					Yes	No
JP 6 - 2 4 5 9 1 7	9-6-1994	Japan			Abstract	
JP 7 - 2 8 4 4 8 4	10-31-1995	Japan			Abstract	
JP 20 00 -1 5 7 5 0 9	6-13-2000	Japan			Abstract	
JP 20 00 -1 6 6 8 9 8	6-20-2000	Japan			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER**DATE CONSIDERED**

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.